

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Gaillard, et al.

**Serial No.: 10/789,209**

Confirmation No.: 9101

Filed: February 27, 2004

**For: Method of Decreasing the K Value in SIOC Layer Deposited by Chemical Vapor Deposition**


**Group Art Unit: 2818**

Examiner: David Nhu

**MAIL STOP AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING  
37 CFR 1.8

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Dear Sir:

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The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

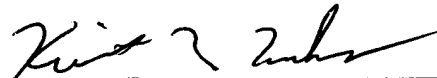
While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

The Commissioner is hereby authorized to charge the sum of \$180.00 due under 37 CFR § 1.17(p) pursuant to § 1.97, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/2592.C9/KMT.

Respectfully submitted,

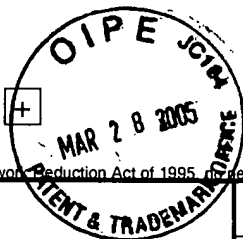


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# **SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Application Number	10/789,209
Filing Date	FEBRUARY 27, 2004
First Named Inventor	GAILLARD, ET AL.
Group Art Unit	2818
Examiner Name	DAVID NHU
Attorney Docket Number	AMAT/2592.C9/DSM/LOW K/JW
Submission Date	3/27, 2005

Sheet 1 of 1

## **U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
	A1	6,846,515 B2	01/25/2005	VRTIS, ET AL.	
	A2	6,825,130 B2	11/30/2004	TODD	
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## **FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
	B1	EP 1 123 991 A2	08/16/2001	MICHAEL A. TODD		
	B2	EP 0 960 958 A2	12/01/1999	LOBODA, ET AL.		
	B3	EP 1 354 980 A1	10/22/2003	VRTIS, ET AL.		

Examiner

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